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DOCKET NO.: 249494US26/ac/bsg

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:
Tamotsu MORIMOTO, et al.

GROUP: 1763

SERIAL NO: 10/796,116

ATTENTION:
FILING RECEIPT CORRECTIONS

FILED: March 10, 2004

FOR: APPARATUS AND METHOD FOR PLASMA PROCESSING

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

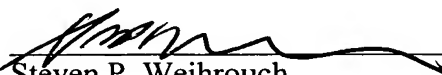
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Sir:

The Patent Office is requested to provide a corrected Official Filing Receipt for the attached. No fees are required. If you have any questions, please do not hesitate to contact us.

Respectfully Submitted,

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
✓ 10/796,116	✓ 03/10/2004	1763	✓ 900	✓ 249494US26	✓ 4	✓ 11	✓ 3

22850
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1940 DUKE STREET
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CONFIRMATION NO. 2485

UPDATED FILING RECEIPT



OC000000013213986

Date Mailed: 07/13/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

✓ TOKYO ELECTRON LIMITED, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

✓ JAPAN 2003-063011 03/10/2003

If Required, Foreign Filing License Granted: 05/27/2004

Projected Publication Date: 10/21/2004

Non-Publication Request: No

Early Publication Request: No

Title

✓ Apparatus and method for plasma processing

Preliminary Class

156

RECEIVED: 7/14/04
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DOCKETING DEPT

Initials/Date Docketed: PP 7/14/04

Type of Resp(s):

Due Date(s):

PLEASE NOTE THAT THE APPLICANTS' CITIES ARE INCORRECT. THEY SHOULD READ AS FOLLOWS:

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